


## Article

# Aluminum Phosphide van der Waals Bilayers with Tunable Optoelectronic Properties under Biaxial Strain

Caixia Mao <sup>1,†</sup>, Hao Ni <sup>1,†</sup> , Libing Qian <sup>1,\*</sup>, Yonghong Hu <sup>1,2,\*</sup> and Haiming Huang <sup>3</sup><sup>1</sup> Hubei Key Laboratory of Radiation Chemistry and Functional Materials, Hubei University of Science and Technology, Xianning 437100, China<sup>2</sup> School of Nuclear Technology and Chemistry & Biology, Hubei University of Science and Technology, Xianning 437100, China<sup>3</sup> School of Science, Hubei University of Automotive Technology, Shiyan 442002, China

\* Correspondence: qianlb@hbust.edu.cn (L.Q.); hchyh2001@tom.com (Y.H.)

† These authors contributed equally to this work.

**Abstract:** The electronic and optical properties of three types of aluminum phosphide bilayers are examined using density functional theory. The results indicate that they all possess proper direct gaps, which exhibit a rich variety of behaviors depending on the strain. The band gaps of these aluminum phosphide bilayers could be easily tuned in the energy range from 0 eV to 1.9 eV under a wide range of biaxial strain. Additionally, band gap transitions between direct and indirect types are found when the external strain applied on them is changed from  $-12\%$  to  $12\%$ . In addition, it was found that these ALP bilayers show strong light-harvesting ability for the ultraviolet light range of the solar spectrum (400–100 nm). The results obtained here indicate that these aluminum phosphide bilayers may have significant potential applications in future nanoelectric fields.

**Keywords:** aluminum phosphide; electronic property; biaxial strain; heterojunction; first-principles calculation



**Citation:** Mao, C.; Ni, H.; Qian, L.; Hu, Y.; Huang, H. Aluminum Phosphide van der Waals Bilayers with Tunable Optoelectronic Properties under Biaxial Strain. *Crystals* **2023**, *13*, 597. <https://doi.org/10.3390/cryst13040597>

Academic Editor: Igor Neri

Received: 19 February 2023

Revised: 17 March 2023

Accepted: 28 March 2023

Published: 1 April 2023



**Copyright:** © 2023 by the authors. Licensee MDPI, Basel, Switzerland. This article is an open access article distributed under the terms and conditions of the Creative Commons Attribution (CC BY) license (<https://creativecommons.org/licenses/by/4.0/>).

## 1. Introduction

Graphene is the first example of two-dimensional (2D) single-layer material, which has opened a new window to nanostructure materials [1,2]. From graphene, a large number of new two-dimensional materials have been synthesized, and the new two-dimensional material family is becoming increasingly large and prosperous. Owing to the electron confinement effect and the absence of interlayer interaction, 2D materials usually differ significantly from their bulk counterparts [3–5]. They also have completely different novel properties, such as electronic structure, optical properties and mechanical properties. The unique combination of excellent physical and chemical properties of 2D materials has aroused enormous attention, and many freestanding monolayer crystals, such as hexagonal BN, transition metal dichalcogenides, antimonene, etc., were systematically studied, leading to various applications [6–8]. The design and development of nanodevices based on new 2D materials promote the rapid development of nanoelectronic technology. It is important for people to design and synthesize novel 2D crystals, and further explore new applications in future nanoelectronic fields.

Aluminum phosphide (ALP) is a typical III–V semiconductor with a proper band gap [9]. In the periodic table, it is in the row next to boron nitride; however, there is relatively little research on it. Its bulk form has many excellent optoelectronic properties and shows magnetic properties after doping of Cr or Ga atoms [9,10]. It has been used to manufacture nanostructure devices, for example, detectors, diodes, spintronics, etc. [10–12]. Novel electronic and magnetic properties of ALP are induced through doping. Therefore, it is also a promising material for new nanoelectric devices [13–15]. As the isoelectronic counterpart of silicone, low-dimensional ALP materials have attracted the interest of many researchers [16–19]. For example, Tong et al. theoretically and firstly described two 2D

single-layer structures of AIP structures (T-structure AIP and V-structure AIP) and their common electronic properties [17]. Hu et al. deeply studied the geometric configurations and electronic properties of V-structure AIP (V-AIP) using first-principles calculation [19]. It is reported that external strain and layer stacking can both be used to modify the geometric configurations as well as the optoelectronic property of the V-AIP monolayer. The V-AIP monolayer belongs to the space group  $Pmn2_1$  and from the top view it has inequilateral hexagonal rings. In a vertical orientation, it resembles a large buckle. The T-AIP monolayer belongs to the space group  $P4/nmm$  and it has a layered structure. The V-AIP monolayer has been found to be stronger than the T-AIP monolayer [18,19]. These AIP monolayers are new 2D semiconductor materials with wide potential application prospects in the near future. As new 2D materials, their properties can be regulated through a variety of physical means, such as doping, defect engineering, stress, electric field, van der Waals stacking and chemical modification [19]. Through van der Waals stacking, especially heterojunction stacking, new physical characteristics different from their constituent units can be induced. At the same time, they have the advantages of their constituent units. Homogeneous van der Waals stacking can also induce new properties. As a simple example, graphene multilayer and monolayer have different infrared light absorption intensities; therefore, in the field of physical therapy, single-layer graphene will be used, and the industrial field may use more than two layers of graphene [2].

As new 2D materials, AIP monolayers provide new building units for van der Waals nanostructures. In experiments, phosphorene-graphene hetero-bilayer structures have already been synthesized and they possess an intrinsic Schottky contact at the photonic crystal interface, in which the Schottky barrier can be modulated by strains and electric fields. Subsequent to this progress, it is natural to explore hetero-systems composed of T-AIP and V-AIP. Here, we perform comprehensive investigation on the structures and properties of V-AIP/V-AIP, T-AIP/T-AIP and T-AIP/V-AIP bilayers. This study offers new insights into the optoelectronic properties of AIP bilayers through strain engineering, which can be exploited in the design of new optoelectronic devices based on 2D AIP materials.

## 2. Methods

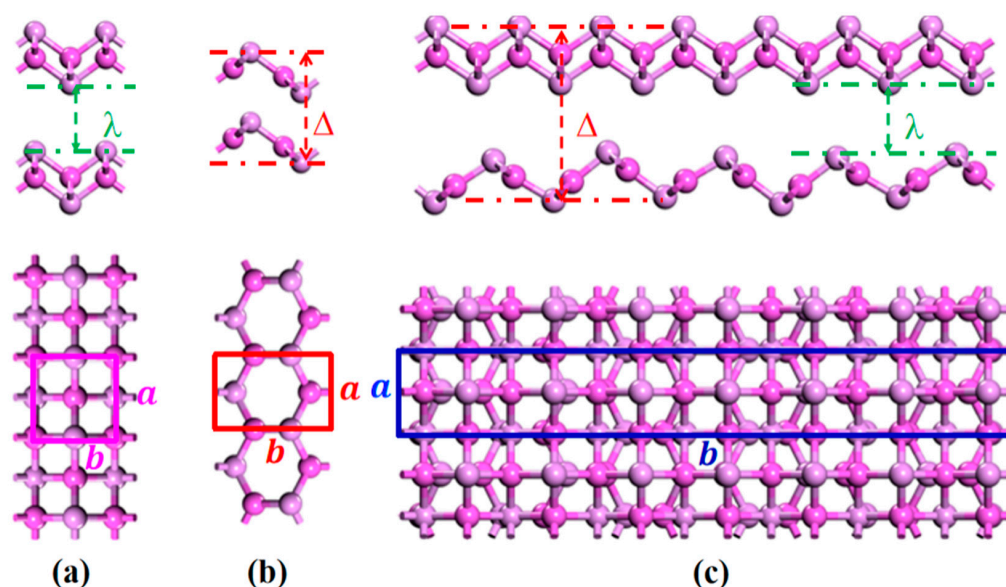
All the crystal structures of AIP bilayers are optimized before calculating their material properties. The calculations of the electronic properties of AIP bilayers are performed in CASTEP [20]. The Perdew–Burke–Ernzerhof functional and the Heyd–Scuseria–Ernzerhof hybrid functional are both used, and in the following they are labeled as PBE functional and HSE06 functional, respectively [21–24]. The vacuum region adopted is greater than 20 Å. The van der Waals (vdW) calculation is performed based on the Tkatchenko–Scheffler approaches [25]. The basis set of valence electronic states is set to be  $3s^2 3p^1$  for Al and  $3s^2 3p^3$  for P, respectively. The kinetic energy cutoff for the plane-wave expansion is set to 1000 eV. The energy convergence criterion was set to  $10^{-7}$  eV. All the structures were relaxed until the largest forces were less than  $10^{-5}$  eV/Å. The definitions of cohesive energy and biaxial uniform strain are the same as in reference [19].

## 3. Results and Discussions

### 3.1. Structural Properties

The crystal structures of the AIP bilayer after full relaxation are shown in Figure 1. The characteristic parameters of the 2D AIP bilayers (for comparison, the parameters of two type AIP monolayer are also provided) are listed in Table 1. For abbreviation, the three types of AIP bilayers, T-AIP/V-AIP, T-AIP/T-AIP and V-AIP/V-AIP, are indicated by T/V-AIP, T-AIP and V-AIP, respectively, in the following. Stacking orders can significantly influence the energy band gap of bilayer van der Waals crystal. It is also necessary to research the influence of layer stacking order on the energy band gap of the AIP bilayers. In the AA-stacking pattern, the two AIP sheets are aligned without any rotation or displacement. For the AB-stacking pattern, the two AIP sheets shift along the lattice vector for a distance of half a cell. We optimized the bilayers of V-AIP and T-AIP in the AA and AB stacking

orders. It was found that different stacking patterns cause almost no difference in structural parameters (lattice constants, bond lengths, etc). Interestingly, it was found that AA stacking of both V-AIP and T-AIP bilayers is energetically favorable for their lower total energy, which are, respectively, 16.7 meV and 11.6 meV per atom lower than those of AB-stacked layers. Therefore, in the following section, the AIP bilayer structures are formed by vertical AA stacking with weak interlayer vdW interaction [19,25].

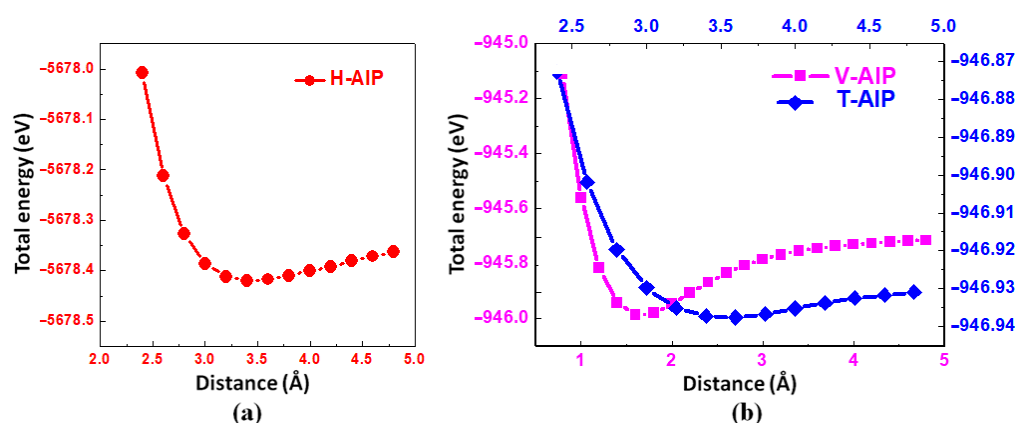


**Figure 1.** The geometry structures of (a) T-AIP; (b) V-AIP and (c) T/V-AIP bilayers. The two symbols  $a$  and  $b$  are lattice parameters. The symbols  $\lambda$  and  $\Delta$  represent vertical distances between the inner- and outer-layer atoms respectively.

**Table 1.** The parameters of the 2D AIP crystals: lattice parameter ( $a$  and  $b$ ), average bond lengths ( $l$ ), cohesive energy ( $E_{coh}$ ) and band gap ( $E_g$ ). The unit of energy is electron volts (eV), and that of length is angstroms (Å). Thickness  $\Delta$ (Å) is defined by the vertical distance and it is shown in Figure 1. The distance  $\lambda$ (Å) between the upper layer and the lower layer is defined by the vertical distance between the lower- and upper-layer atoms in these 2D material models, as is also shown in Figure 1.

Model	$a, b$ (Å)	$l$	$\Delta$	$\lambda$	$E_{coh}$	$E_g$
V-AIP monolayer	$a = 3.81, b = 5.68$	2.32	2.2	—	−5.12	2.62
T-AIP monolayer	$a = b = 3.91$	2.43	2.9	—	−5.35	0.97
V-AIP bilayer	$a = 3.81, b = 5.68$	2.34	6.2	1.6	−5.00	1.86
T-AIP bilayer	$a = b = 3.89$	2.27	8.8	3.6	−4.85	1.29
T/V-AIP bilayer	$a = 3.85, b = 28.4$	2.37	8.6	3.4	−4.94	0.86

To obtain the most stable bilayer structures of AIP, we examine the total energy of the systems with various distances between the two layers, as shown in Figure 2. It is found that the distance between the two layers of the three most stable vdW bilayer structures are 3.4 Å, 3.6 Å and 1.6 Å, respectively. The lattice constants' mismatch of the T-AIP and V-AIP in the T/V-AIP bilayer crystal is below 1.5%, which is tolerable. The vertical distances between the two layers (distances between the two dashed lines in Figure 1) are 3.4 Å, 3.6 Å and 1.6 Å respectively, which are in consistent with the vdW interactions. In these stable vdW bilayer systems, the two layers of AIP are combined with each other via vdW interactions. To examine the kinetic stabilities of these three types of AIP bilayers, their cohesive energy values are calculated and compared.



**Figure 2.** The total energy of the three systems versus the interlayer distance. (a) The case for T/V-AIP bilayers; (b) the case for T-AIP and V-AIP bilayers.

As shown in the cohesive energy values in Table 1, it was found that all the AIP bilayers have high thermal stability, which is indicated by the negative values (the values are  $-4.94$ ,  $-4.85$  eV and  $-5.00$  eV for the T/V-AIP, T-AIP and V-AIP bilayers, respectively) [26]. The thermal stability of V-AIP is slightly better than that of the T/V-AIP and T-AIP bilayers. The cohesive energy of the blue phosphorene monolayer is  $-5.18$  eV, and it almost equals these AIP bilayers [27]. The thickness of the AIP monolayer and bilayers are shown and compared in Table 1. It is found that the thickness value of the T/V-AIP bilayer is between those of the T-AIP bilayer and the V-AIP bilayer, and the thickness of the V-AIP bilayer is 30% thinner than that of the T-AIP bilayer. The average bond length of the V-AIP monolayer is  $0.02$  Å shorter than that of the V-AIP bilayer, while the average bond length of the T-AIP monolayer is  $0.16$  Å longer than that of the T-AIP bilayer. Of the three AIP bilayers, the average bond length of the T/V-AIP bilayer is the longest, and the average bond length of the T-AIP bilayer is the shortest.

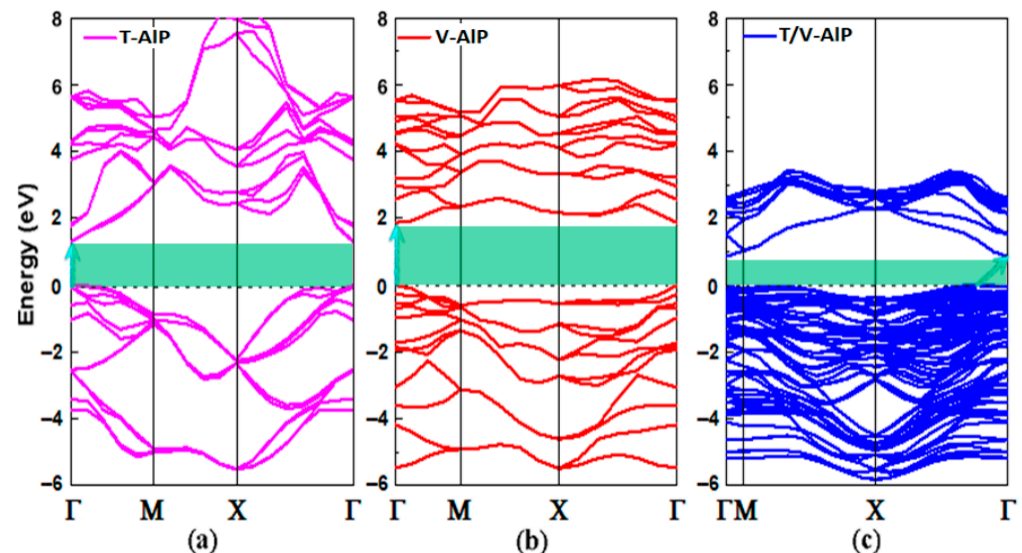
### 3.2. Electronic Properties

The band structures of these AIP bilayer systems are calculated in detail, as shown in Figure 3. As shown in Figure 3a,b, the direct band gaps (the cyan arrows) of  $1.29$  eV and  $1.86$  eV are obtained for the T-AIP and V-AIP bilayers, respectively. As shown in Figure 3c, the indirect band gap of  $0.86$  eV is obtained for the T/V-AIP bilayer. The indirect band gap characteristic of 2D material is a well-known shortcoming of their application in optoelectronic devices. Therefore, the electronic properties of T/V-AIP bilayers are to be modified by some physical method in a potential semiconductor for optoelectronic devices.

In Figure 4, the projected density of states (PDOS) of the AIP bilayers are shown. The Mulliken layout analysis of is provided in Table S1. It is found that the valence band edges for all AIP bilayers are contributed mainly by the p orbitals of P atoms. For the conduction band edge, it is determined by s orbitals of Al atoms in T-AIP bilayer (As shown in Figure 4a) and p orbitals of Al atoms in the V-AIP bilayer (As shown in Figure 4b, which also exhibit no difference from their monolayers [18,19]). In Figure 4c, it is shown that the s orbitals of Al atoms determine the conduction band edge in the T/V-AIP bilayer. The electron density difference maps of the T-AIP, V-AIP and T/V-AIP bilayers are given in Figure S1. This is in consistent with its low energy band gap compared with those of the T-AIP and V-AIP bilayers.

External in-plane strain is proved to be an effective physical method to tune the geometric configuration and common physical properties of 2D crystals [28,29]. However, the electronic property of graphene is not sensitive to external strain [30]. Hence, on one hand we are interested in exploring whether applied stress is effective in changing the geometric configurations of AIP bilayers and their electronic properties. On the other hand, we doubt whether the indirect-direct transition of energy band structure of the T-AIP bilayer can be induced by external strain. Therefore, many computations are performed on

these AIP bilayers under a wide range of biaxial strain. The variations in the band gaps of T-AIP, V-AIP and T/V-AIP bilayers versus biaxial strain are plotted in Figure 5. In Figure 6, under the axial strain applied along the lattice direction from 20% to +8%, the direct band gap character of V-AIP is retained. The value of the direct band gap decreases with the increasing tension and compression. As the biaxial tension strain increases, the VBM moves from the G point to a near point and a direct–indirect band gap transition occurs when the tension increases from +8% to +10%. Firstly, the biaxial strain effect on the T-AIP bilayer is considered. As seen in Figure 5, under the biaxial strain from −12% to +12%, the band gap of the T-AIP bilayer changes from 0.53 eV to 1.62 eV. The direct band gap character of the T-AIP bilayer is retained only when the biaxial strain varies from −2% to +2%. As shown in Figure 6, the band gap transition is induced by the competition of the band-edge states. As shown in Figure 5, the band gap of the T-AIP bilayer can be tuned upmost to 1.62 eV at HSE level. The biaxial strain can effectively change the direct band gap of the T-AIP bilayer in a wide range from 1.06 eV to 1.55 eV. The band gap of the T-AIP monolayer is reported to be easily tuned by biaxial strain, and the variation trend upon biaxial strain is analogous to that of the T-AIP bilayer in Figure 5 [18]. The band gap variation trends of T-AIP monolayer and bilayer both increase with biaxial strain, then begin to decrease with the increase in the biaxial strain, but the turning point of the former is −5%, and that of the latter is −4%.



**Figure 3.** Energy band structures of T-AIP, V-AIP and T/V-AIP bilayers. In (a,b), the vertical arrows represent the direct band gaps of T-AIP and V-AIP materials, and the diagonal arrow in (c) represents indirect band gap of the T/V-AIP heterojunction. The horizontal dotted line represents Fermi level and the light green areas denote the bandgap.

Secondly, the influence of external biaxial strain on V-AIP is researched in detail. It can be seen from Figures 5 and 7 that the band gap of the V-AIP bilayer changes from 0.9 eV to 1.9 eV (the blue arrows). The electronic band structure of the V-AIP bilayer is retained when the biaxial strain varies from −12% to +10%. The biaxial strain can change the direct band gap of the V-AIP bilayer in a large range from 0 eV to 1.9 eV. However, in the same biaxial strain range (from −12% to +12%), the direct band gap of the V-AIP monolayer can change in a different range from 0 eV to 2.6 eV [19].



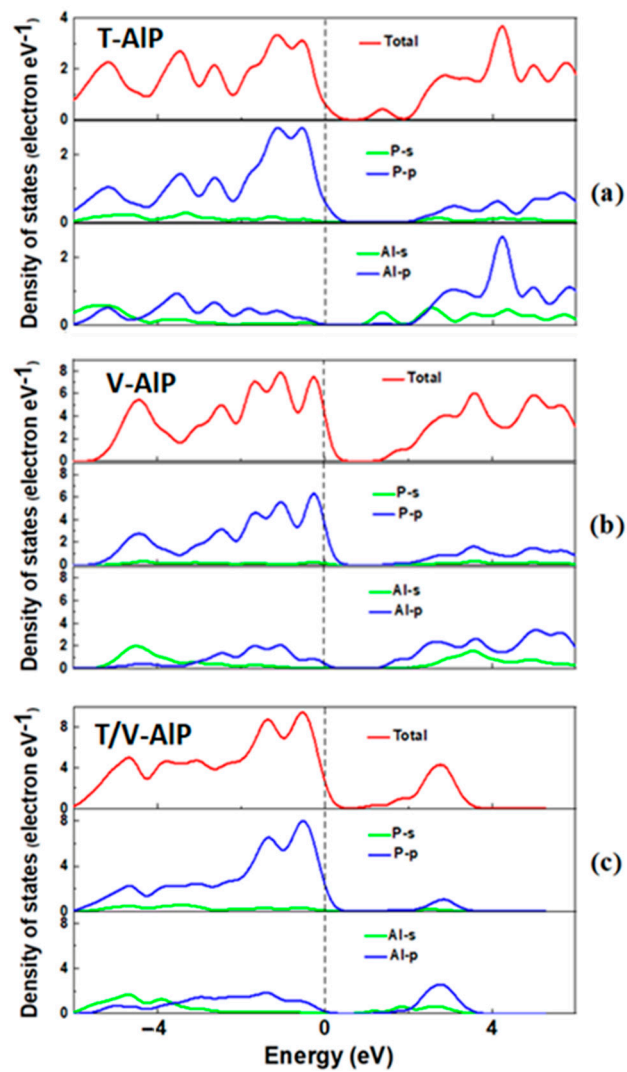


Figure 4. The PDOS of (a) T-AIP, (b) V-AIP and (c) T/V-AIP bilayers. The vertical dotted line represents Fermi level.

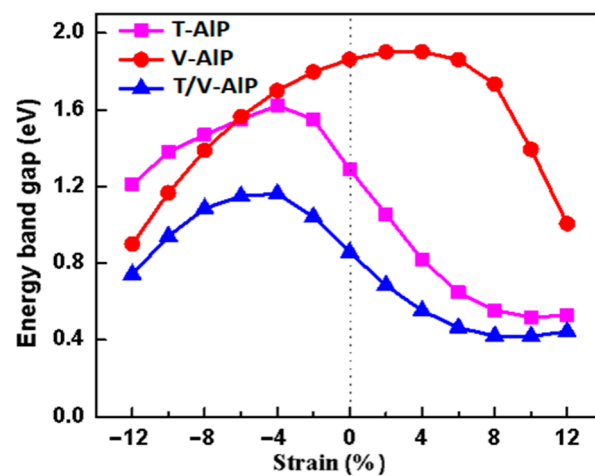
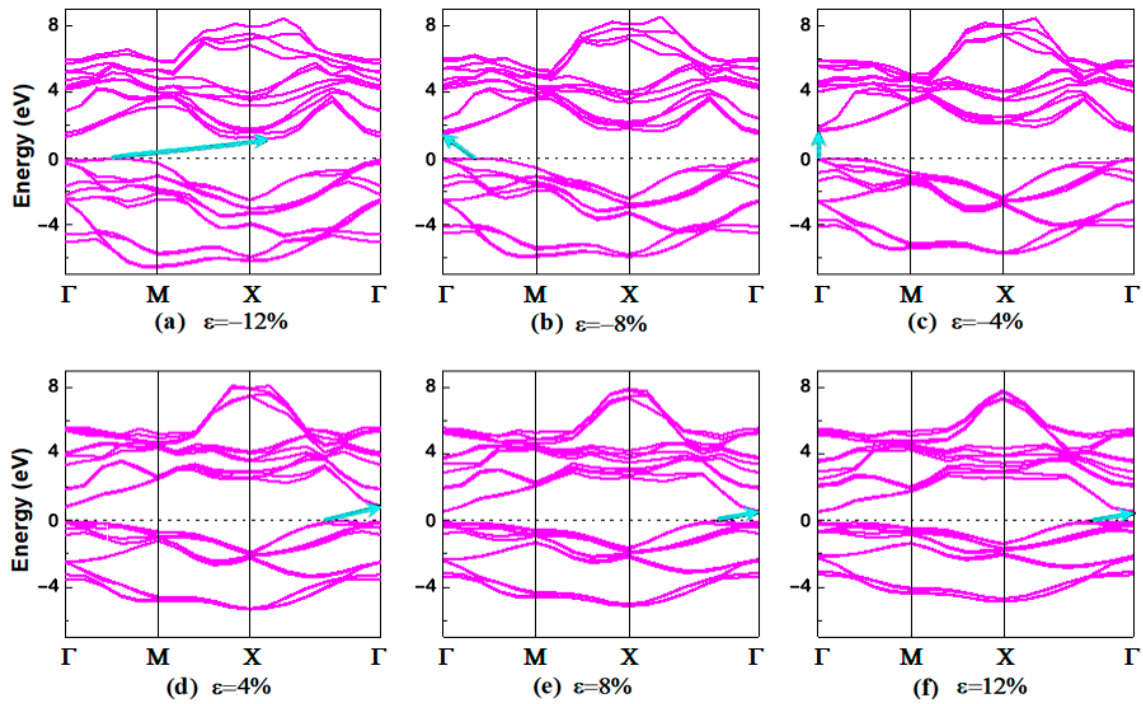
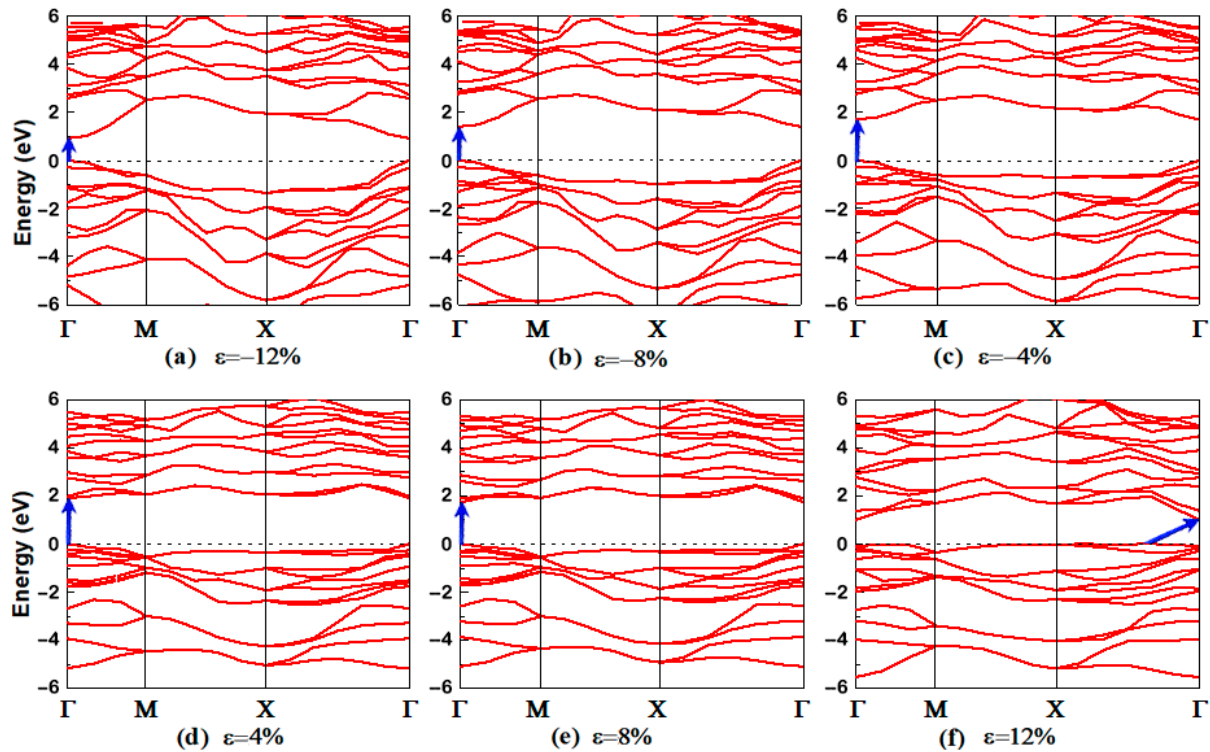


Figure 5. The band gaps of the T-AIP, V-AIP and T/V-AIP bilayers versus biaxial strain. The vertical dotted line corresponds to the unstressed condition. The biaxial strain step is 2% in our work.

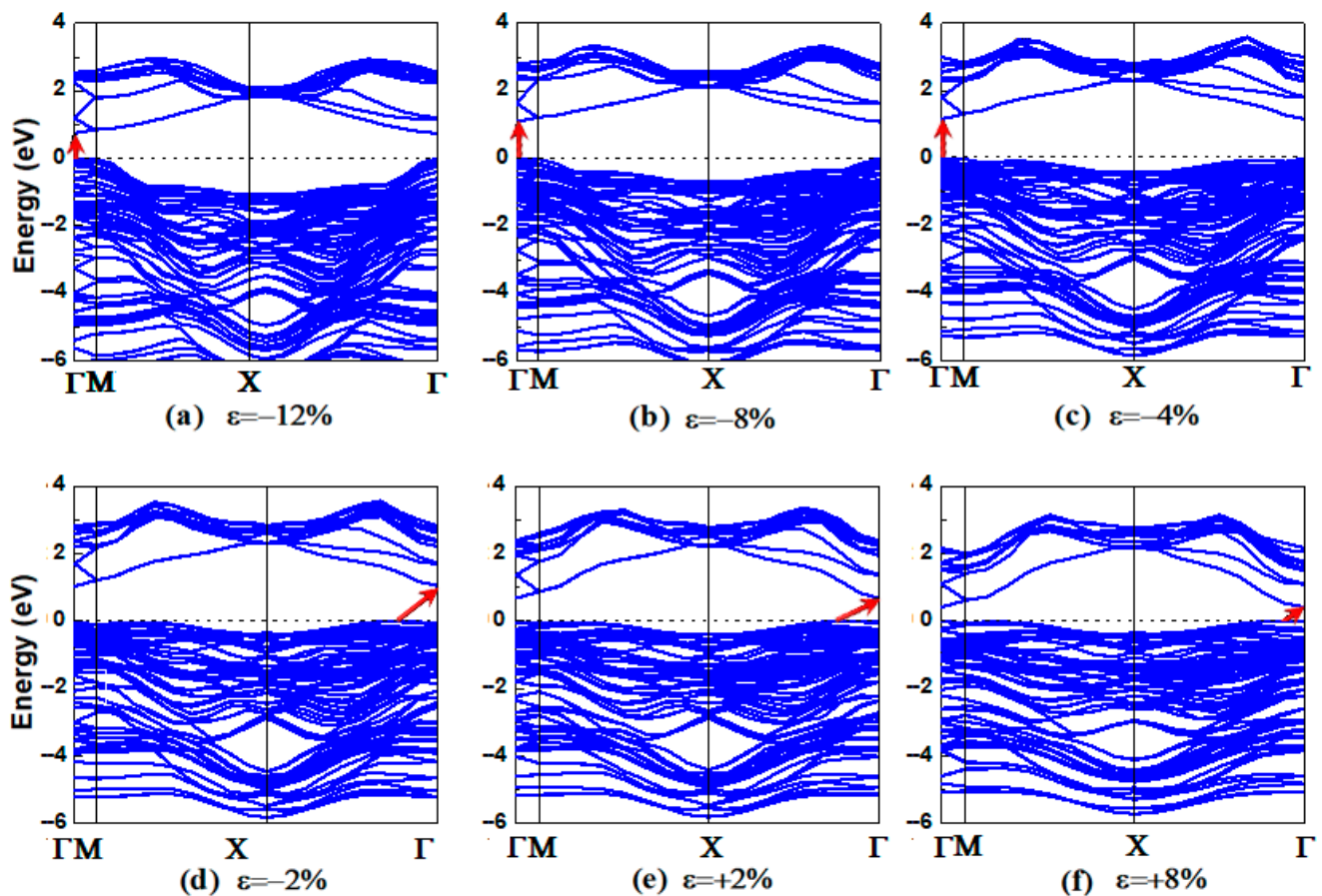


**Figure 6.** Changes in the electronic band structure for the T-AIP bilayer influenced by external strain of (a–f)  $\varepsilon = -12\%$ ,  $-8\%$ ,  $-4\%$ ,  $4\%$ ,  $8\%$ , and  $12\%$ . Here and in the following, the vertical arrow represents the direct band gap, and the diagonal arrow represents the indirect band gap. The horizontal dotted line represents Fermi level.



**Figure 7.** Band structure change for the V-AIP bilayer induced by external biaxial strain. Five cases, including figures (a–e), show the direct band gaps (vertical arrows), while (f) shows an indirect band gap (diagonal arrow).

Lastly, the variation in band structure of the T/V-AIP bilayer induced by biaxial strain is studied. In Figure 5, under the biaxial strain, the band gap of the T/V-AIP bilayer changes from 0.42 eV to 1.16 eV (the cyan arrows). The direct band structure of the T/V-AIP bilayer is retained only when the biaxial strain varies from  $-12\%$  to  $+1\%$ . As the biaxial tension strain increases, the VBM moves from the G point to a nearby point and a direct-indirect band gap transition takes place when the tension increases from  $+10\%$  up to  $+12\%$ , which is shown in Figure 8. The direct band gap of the T/V-AIP bilayer is changed from 0 eV to 1.16 eV by applying biaxial strain (the red arrows).



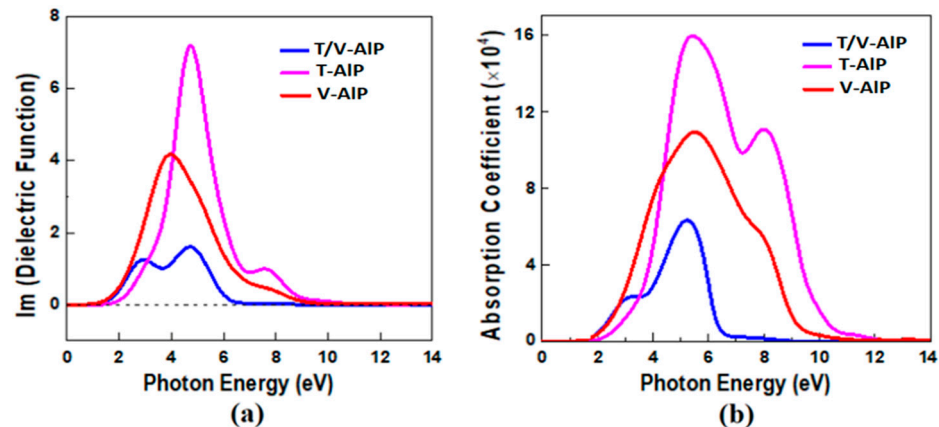
**Figure 8.** Band structure change and the band edge shift under biaxial strain for the T/V-AIP bilayer based on HSE functional. In the case of compression, figures (a–c) show direct band gaps (vertical arrows), while in the case of tension, figures (d–f) show indirect band gaps (diagonal arrows).

### 3.3. Optical Properties

The optical properties can be described by the dielectric function as  $\epsilon(\omega) = \epsilon_1(\omega) + i\epsilon_2(\omega)$ . The imaginary part of the dielectric function  $\epsilon_2(\omega)$  is an important factor of 2D material, which contains much information about the energy band structure, and various optical spectra can be calculated from it. We plotted the dielectric functions and absorption coefficients, the reflectivity and the extinction coefficient of the three types of AIP bilayers in Figure 9. It can be seen in Figure 9a that the imaginary part of the dielectric function of AIP bilayers exhibits different peaks; the corresponding photon energies are 2.93 eV, 4.70 eV for the T/V-AIP bilayer, 4.74, 7.56 for the T-AIP bilayer and 3.98 eV for the V-AIP bilayer, respectively. It is clear that the peak of the T/V-AIP bilayer is much higher than the others. Compared with the V-AIP and T-AIP bilayers, the first dielectric peak of T/V-AIP shows a slight shift (red shift), which corresponds to the narrow band gap in Figure 3. It was found that  $\epsilon_2(\omega)$  has two obvious peaks except for the V-AIP bilayer. The dielectric peak of V-AIP first rises significantly, arriving at its top value at an energy of 3.98 eV, and in the following it falls obviously. The

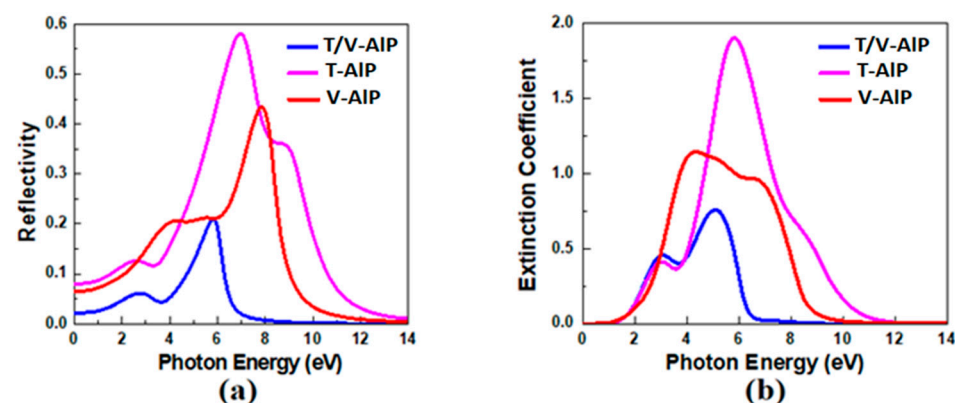


absorption spectra of different AIP bilayers are shown in Figure 9b. The V-AIP bilayer exhibits the highest absorption spectrum peak among the three types of AIP bilayers. It can be seen in Figure 9b that the absorption function of AIP bilayers exhibits different peaks; the corresponding photon energies are 5.23 eV for the T/V-AIP bilayer, 5.43 eV, 8.00 eV for the T-AIP bilayer and 5.51 eV for V-AIP bilayer, respectively. These absorption peaks with the energies of 5.23 eV and 8.00 eV lie in the ultraviolet (UV) range (10–400 nm), indicating these AIP bilayers have potential applications in the UV and far-UV light detector fields.



**Figure 9.** (a) The imaginary dielectric function; (b) the absorption spectra of the AIP bilayers. Curves of different colors represent the optical spectra of the different types of AIP bilayer materials.

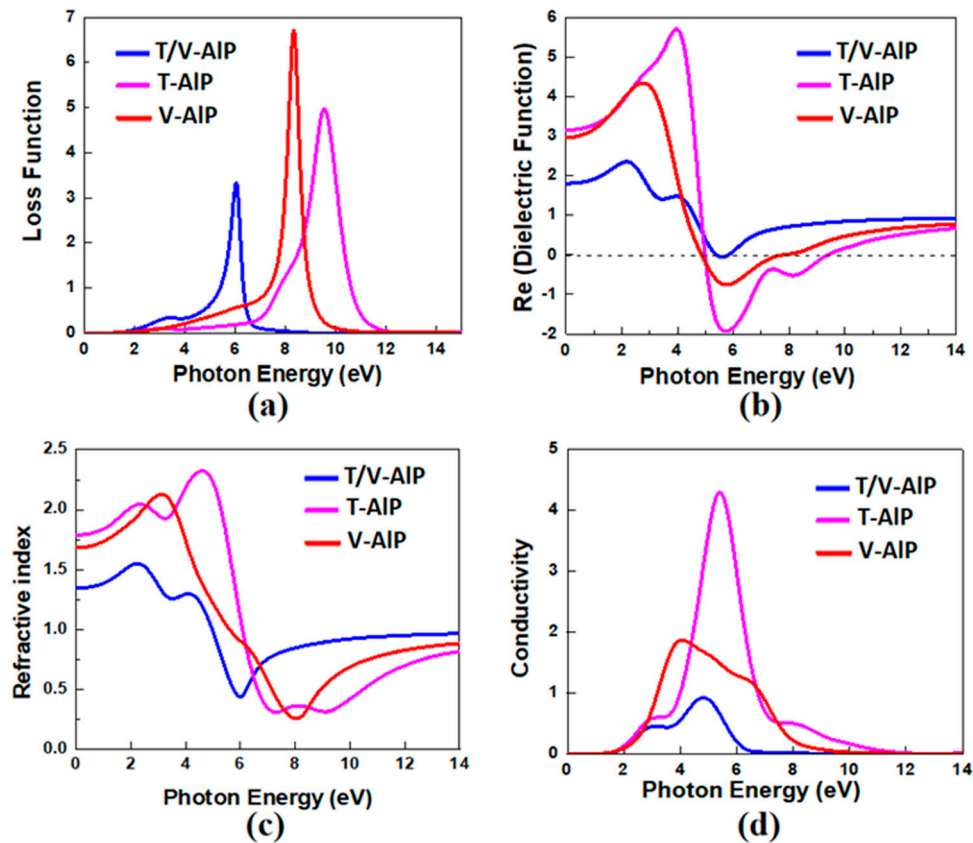
It can be seen in Figure 10a that the reflectivity of the AIP bilayers exhibits different peaks; the corresponding photon energies are 3.4 eV and 6.0 eV for the T/V-AIP bilayer, 9.5 eV for the T-AIP bilayer and 8.3 eV for the V-AIP bilayer, respectively. From Figure 10b, it is found that the extinction coefficient of AIP bilayers exhibits five different peaks; the corresponding photon energies are 3.1 eV and 5.1 eV for the T/V-AIP bilayer, 3.0 eV and 5.8 eV for the T-AIP bilayer and 4.3 eV for the V-AIP bilayer, respectively.



**Figure 10.** (a) The reflectivity and (b) the extinction coefficient of the three types of AIP bilayers.

The remaining optical spectra of the AIP bilayers, such as loss function, refractive index and conductivity, are shown in Figure 11. They are also important factors in evaluating the AIP bilayers and their optical applications. From Figure 11a, it is found that the energy loss peaks' energy positions are in agreement with those of the reflectivity spectrum tail edge. It is found that the energy loss of the AIP bilayers exhibits four different peaks; the corresponding photon energies are 3.4 eV and 6.0 eV for the T/V-AIP bilayer, 9.5 eV for the T-AIP bilayer and 8.3 eV for the V-AIP bilayer, respectively. The loss function spectrum peaks and reflectivity spectrum peaks of these AIP bilayers all emerge at the energy position of 6.0 eV, 9.5 eV and 8.3 eV. In Figure 11b, it can be seen that the real part of the dielectric function in the T-AIP bilayer is negative in the range from 5.0 eV to 9.4 eV. Additionally,

that of the V-AIP bilayer is negative in the range of 4.7–7.7 eV. Figure 11b also shows the real dielectric spectrums of the T/V-AIP bilayer, and it can be found that the transition between the dielectric property and the metallic property will happen when the photon energy changes at approximately 4.0 eV and 10.0 eV.



**Figure 11.** (a) The loss function; (b) the real part of dielectric function; (c) the refractive index and (d) the conductivity of the three types of AIP bilayers.

The refractive index and conductivity spectra of AIP bilayers are plotted in Figure 11c,d. As shown in Figure 11c, the real refractive index of AIP bilayers are 1.34, 1.79 and 1.68 for the T/V-AIP, T-AIP and V-AIP bilayers, respectively. It can be seen from Figures 10b and 11d that the curves of the conductivity spectra of AIP bilayers have similar shapes to their extinction coefficient spectra, and their peaks also have the same energy positions.

#### 4. Conclusions

In summary, we have systematically studied the electronic band structure and optical properties of the three types of AIP bilayers. The high stabilities of the three types of AIP bilayers are proved by considering their binding energy. Interestingly, the T-AIP and V-AIP bilayers both possess direct band gaps, which are useful in nanoelectronic devices. These band gaps exhibit remarkably diverse behavior induced by changes to the biaxial strain applied. Under biaxial strain, the electronic band structures and band gaps of AIP bilayers can be tuned in different ranges. In particular, the indirect energy band gap of the T/V-AIP bilayer is tuned into a direct band gap by applying biaxial compressive strain. The tunable range of the direct band gap of the T-AIP bilayer is from 1.06 eV to 1.55 eV, that of the T/V-AIP bilayer is from 0 eV to 1.16 eV, and that of the V-AIP bilayer is from 0 eV to 1.9 eV. The AIP bilayers show novel optical properties, especially strong light absorption in the UV range of the sunlight spectrum. Therefore, these 2D AIP bilayers have potential applications in nanoelectronic fields. These results provide important reference and information for the design of new nanoelectric devices based on AIP materials.

**Supplementary Materials:** The following supporting information can be downloaded at: <https://www.mdpi.com/article/10.3390/cryst13040597/s1>, Table S1: Mulliken layout analysis of T-AIP, V-AIP and T/V-AIP bilayers; Figure S1: The electron density difference maps of (a) T-AIP, (b) V-AIP and (c) T/V-AIP bilayers. The top view and front view are both displayed for each AIP bilayer.

**Author Contributions:** Conceptualization, C.M. and Y.H.; methodology, H.N.; validation, L.Q.; formal analysis, H.N.; investigation, C.M. and Y.H.; resources, L.Q. and Y.H.; data curation, H.H.; writing—original draft preparation, C.M. and Y.H.; writing—review and editing, Y.H. and H.N.; visualization, H.N. and H.H.; supervision, Y.H.; project administration, C.M.; funding acquisition, Y.H. and L.Q. All authors have read and agreed to the published version of the manuscript.

**Funding:** This research was funded by the Research Foundation of Educational Commission of Hubei Province, grant number B2020153, the Scientific Research Project and Innovation Team of Hubei University of Science and Technology, grant number HKCXTD-001, the Research Project of Hubei Key Laboratory of Radiation Chemistry and Functional Materials and Hubei University of Science and Technology, grant number 2021ZX02, 2020-21X26 and 2020-22GP01, the National Undergraduate Innovation and Entrepreneurship Plan Training Program, grant number 202210927002, the Key Incubation Projects for Innovation and Entrepreneurship at Hubei University of Science and Technology, grant number 2022-026 and the Program for Science and Technology Innovation Team in Colleges of Hubei Province, grant number T2021012.

**Data Availability Statement:** The data presented in this study are available upon request.

**Conflicts of Interest:** The authors declare no conflict of interest.

## References

- Novoselov, K.S.; Geim, A.K.; Morozov, S.V.; Jiang, D.; Zhang, Y.; Dubonos, S.V.; Grigorieva, I.V.; Firsov, A.A. Electric field effect in atomically thin carbon films. *Science* **2004**, *306*, 666–669. [\[CrossRef\]](#)
- Huang, Y.; Zhu, C.; Zhang, S.; Hu, X.; Zhang, K.; Zhou, W.; Guo, S.; Xu, F.; Zeng, H. Ultrathin Bismuth Nanosheets for Stable Na-Ion Batteries: Clarification of Structure and Phase Transition by in Situ Observation. *Nano Lett.* **2019**, *19*, 1118–1123. [\[CrossRef\]](#) [\[PubMed\]](#)
- Ashton, M.; Mathew, K.; Hennig, R.G.; Sinnott, S.B. Predicted Surface Composition and Thermodynamic Stability of MXenes in Solution. *J. Phys. Chem. C* **2016**, *120*, 3550–3556. [\[CrossRef\]](#)
- Ashton, M.; Paul, J.; Sinnott, S.B.; Hennig, R.G. Topology-Scaling Identification of Layered Solids and Stable Exfoliated 2D Materials. *Phys. Rev. Lett.* **2017**, *118*, 10610. [\[CrossRef\]](#) [\[PubMed\]](#)
- Geim, A.K. Graphene: Status and Prospects. *Science* **2009**, *324*, 1530–1534. [\[CrossRef\]](#)
- Zhang, Y.; Dong, N.; Tao, H.; Yan, C.; Huang, J.; Liu, T.; Robertson, A.W.; Texter, J.; Wang, J.; Sun, Z.Y. Exfoliation of stable 2D black phosphorus for device fabrication. *Chem. Mater.* **2017**, *29*, 6445–6456. [\[CrossRef\]](#)
- Zhang, S.; Guo, S.; Ma, Y.; Chen, Z.; Wang, Y.; Gao, H.; Herrero, J.G.; Ares, P.; Zamora, F.; Zhou, Z.; et al. Recent progress in 2D group-VA semiconductors: From theory to experiment. *Chem. Soc. Rev.* **2018**, *47*, 982–1021. [\[CrossRef\]](#)
- Niu, T.; Zhou, W.; Zhou, D.; Hu, X.; Zhang, S.; Zhang, K.; Zhou, M.; Fuchs, H.; Zeng, H. Modulating Epitaxial Atomic Structure of Antimonene through Interface Design. *Adv. Mater.* **2019**, *31*, 1902606. [\[CrossRef\]](#)
- Zhang, Y.; Liu, W.; Niu, H. Half-metallic ferromagnetism in Cr-doped AIP—Density functional calculations. *Solid State Commun.* **2008**, *145*, 590–593. [\[CrossRef\]](#)
- Zhang, Y. Possible room temperature ferromagnetism in Ca-doped AIP: First-principles study. *J. Magn. Magn. Mater.* **2013**, *342*, 35–37. [\[CrossRef\]](#)
- Liang, P.; Liu, Y.; Hu, X.; Wang, L.; Dong, Q.; Jing, X. The half metallic property and electronic structure of the Ti doped AIP systems investigated by first principle. *J. Magn. Magn. Mater.* **2014**, *355*, 295–299. [\[CrossRef\]](#)
- Yan, Z.; Wu, H.; Zheng, R. Ferromagnetism in alkali-metal-doped AIP: An ab initio study. *Comput. Mater. Sci.* **2015**, *99*, 16–20. [\[CrossRef\]](#)
- Boutaleb, M.; Doumi, B.; Tadjer, A.; Sayede, A. Half-metallic ferromagnetic properties of Cr- and V-doped AIP semiconductors. *J. Magn. Magn. Mater.* **2016**, *397*, 132–138. [\[CrossRef\]](#)
- Wang, S.; Fan, X.; An, Y. Room-temperature ferromagnetism in alkaline-earth-metal doped AIP: First-principle calculations. *Comput. Mater. Sci.* **2018**, *142*, 338–345. [\[CrossRef\]](#)
- Chen, Y.; Xing, Y.; Jiang, A.; Zhou, C.; Lu, S. Enhanced optical absorption in visible range in Mn doped AIP: A density functional theory study. *J. Magn. Magn. Mater.* **2018**, *457*, 13–16. [\[CrossRef\]](#)
- Sun, J. Stability and Electronic Structures of Single-Walled Alp Nanotubes by First Principle Study. *Procedia Eng.* **2011**, *15*, 5062–5066.
- Tong, C.; Zhang, H.; Zhang, Y.; Liu, H.; Liu, L. New manifold two-dimensional single-layer structures of zinc-blende compounds. *J. Mater. Chem. A* **2014**, *2*, 17971–17978. [\[CrossRef\]](#)

18. Liu, C.; Teng, Z.; Ye, X.; Yan, X. Two-dimensional tetragonal AlP monolayer: Strain-tunable direct–indirect band-gap and semiconductor–metal transitions. *J. Mater. Chem. C* **2017**, *5*, 5999–6004. [[CrossRef](#)]
19. Yang, X.; Mao, C.; Hu, Y.; Cao, H.; Zhang, Y.; Zhao, D.; Chen, Z.; Xie, M. Two-dimensional aluminum phosphide semiconductor with tunable direct band gap for nanoelectric applications. *RSC Adv.* **2020**, *10*, 25170–25176. [[CrossRef](#)]
20. Vanderbilt, D. Soft self-consistent pseudopotentials in a generalized eigenvalue formalism. *Phys. Rev. B* **1990**, *41*, 7892–7895. [[CrossRef](#)]
21. Perdew, J.P.; Zunger, A. Self-interaction correction to density-functional approximations for many-electron systems. *Phys. Rev. B* **1981**, *23*, 5048–5079. [[CrossRef](#)]
22. Perdew, J.P.; Burke, K.; Ernzerhof, M. Generalized gradient approximation made simple. *Phys. Rev. Lett.* **1996**, *77*, 3865–3868. [[CrossRef](#)] [[PubMed](#)]
23. Heyd, J.; Scuseria, G.E.; Ernzerhof, M. Hybrid functionals based on a screened Coulomb potential. *J. Chem. Phys.* **2003**, *118*, 207–8215. [[CrossRef](#)]
24. Monkhorst, H.J.; Pack, J.D. Special points for Brillouin-zone integration. *Phys. Rev. B* **1976**, *13*, 5188–5192. [[CrossRef](#)]
25. Tkatchenko, A.; Scheffler, M. Accurate molecular van der Waals interactions from ground-state electron density and free-atom reference data. *Phys. Rev. Lett.* **2009**, *102*, 073005. [[CrossRef](#)]
26. Mao, Y.; Xu, C.; Yuan, J.; Zhao, H. Effect of stacking order and in-plane strain on the electronic properties of bilayer GeSe. *Phys. Chem. Chem. Phys.* **2018**, *20*, 6929–6935. [[CrossRef](#)]
27. Zhang, K.; Feng, S.; Wang, J.; Azcatl, A.; Lu, N.; Addou, R.; Wang, N.; Zhou, C.; Lerach, J.; Bojan, V. Correction to manganese doping of monolayer MoS<sub>2</sub>: The substrate is critical. *Nano Lett.* **2016**, *16*, 2125. [[CrossRef](#)]
28. Qu, H.; Zhou, W.; Guo, S.; Li, Z.; Wang, Y.; Zhang, S. Ballistic Quantum Transport of Sub-10 nm 2D Sb<sub>2</sub>Te<sub>2</sub>Se Transistors. *Adv. Bioelectron. Mater.* **2019**, *5*, 1900813. [[CrossRef](#)]
29. Zhang, S.; Hu, Y.; Hu, Z.; Cai, B.; Zeng, H. Hydrogenated arsenenes as planar magnet and Dirac material. *Appl. Phys. Lett.* **2015**, *107*, 022102. [[CrossRef](#)]
30. Choi, S.M.; Jhi, S.H.; Son, Y.W. Effects of strain on electronic properties of graphene. *Phys. Rev. B* **2010**, *81*, 081407. [[CrossRef](#)]

**Disclaimer/Publisher’s Note:** The statements, opinions and data contained in all publications are solely those of the individual author(s) and contributor(s) and not of MDPI and/or the editor(s). MDPI and/or the editor(s) disclaim responsibility for any injury to people or property resulting from any ideas, methods, instructions or products referred to in the content.